**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: THEODORE M. TAYLOR AND

STEPHEN J. KRAMER

FILED:

**CONCURRENTLY HEREWITH** 

For:

METHODS FOR REMOVING DOPED POLYSILICON FROM MICROFEATURE

**WORKPIECES** 

## **Preliminary Amendment**

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Commissioner:

Prior to examination on the merits, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2.